

# (SG1, MAP) Session Report



Date: May 21, 2024

May 22, 2024 (M. Shoji)

Time: 9:42 – 16:43

Shot#: 191511 – 191631 (121 shots)

Prior wall conditioning: He GDC

Divertor pump: Off

Gas puff: He, H<sub>2</sub>

Pellet: TESPEL

NBI#(1, 2, 3, 4, 5) = gas(H, H, H, H, H)=P(4.5, 4.4, 4.3, 3.7, 3.4) MW

ECH(77GHz) = ant(1.5-Uo, 5.5-U, 2-OUR)=P(-, 0.69, 0.38) MW

ECH(154GHz) = ant(2-OLL, 2-OUL, 2-OLR)=P(0.71, 0.89, 0.98) MW

ICH(3.5U, 3.5L, 4.5U, 4.5L) = P(?, ?, ?, ?) MW

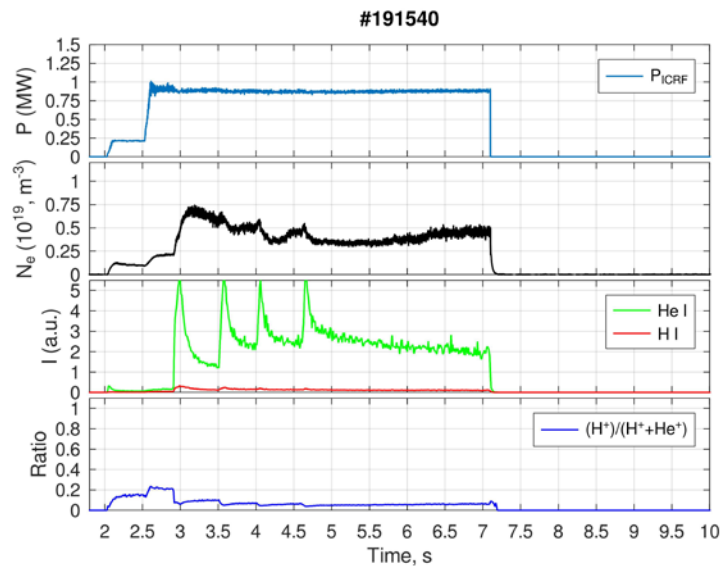
## Topics

1. RF plasma production at relatively low magnetic fields for wall conditioning (Y. Kovtun(KIPT), T. Seki)
2. Micro-trench measurement of incident ion angles and boron deposition at the divertor surface (S. Abe(PPPL), S. Masuzaki)
3. Mitigation of tungsten-induced plasma termination and identification of transient transport mechanisms (H. Bouvain(IPP), N. Tamura)

# RF plasma production at relatively low magnetic fields for wall conditioning

(Y. Kovtun, T. Seki, V. Moiseyenko)

Experimental conditions:  $(R_{ax}, \text{Polarity}, B_t, \gamma, B_q) = (3.6 \text{ m}, \text{CW}, 0.4 \text{ T}, 1.254, 100.0\%)$  Shots: #191515 - #191565



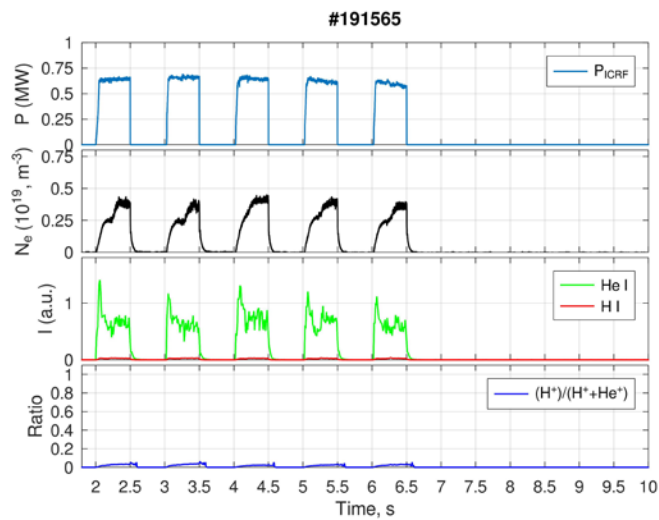
## Goal of this experiment:

- To study the plasma production with only ICRF heating (higher harmonic cyclotron resonance conditions) on the low magnetic field configuration in He plasmas for wall conditioning

## Results:

- Different scenarios of ICRF plasma production under constant gas flow and additional gas injection have been made out.
- In all scenarios, stable RF breakdown and plasma creation are observed.
- The plasma density is observed to be  $6 \times 10^{18} \text{ m}^{-3}$  at an injected power of 0.9 MW.
- The achieved densities were proportional to the injection power of ICRF.

Checking the neutral pressure and these contents using QMS



# Micro-trench measurement of incident ion angles and boron deposition at the divertor surface

S. Abe (PPPL), S. Masuzaki

Shot #: 191566 – 191586 (sample exposure: 191582-191586)

$(R_{ax}, B_t, \gamma, B_q) = (3.6 \text{ m}, 2.75 \text{ T}, 1.2538, 100.0\%)$

Working gas: He

$P_{ECH} \sim 3 \text{ MW}$ ,  $P_{t-NBI} \sim 12 \text{ MW}$ ,  $P_{p-NBI} \sim 6 \text{ MW}$  (modulated)

## Objectives

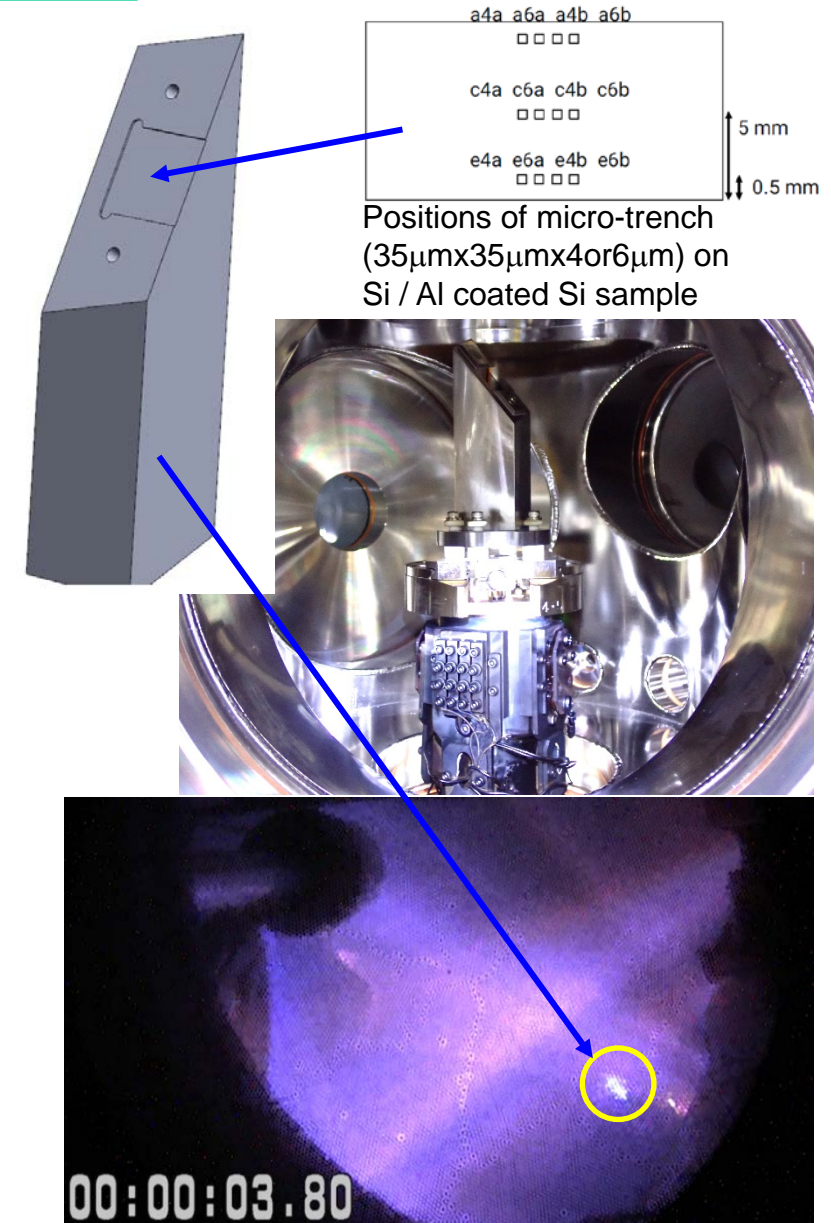
- Measurements on the incident ion angle (IIA) for both polar and azimuthal directions of H and He ions at ITER-relevant magnetic-field incident angle,  $\alpha \sim 86^\circ$  (referenced to the surface normal).
- Measurements on boron gross deposition transported from the impurity powder dropper (IPD).

## Method

- The sample holder designed to have the Si crystal surface and Al-coated Si crystal surface at  $\alpha \sim 86^\circ$  is installed in LHD using the 4.5L manipulator. We expose two micro-trench fabricated Si crystals for each H and He shots.
- Surface analysis using SEM-EDS.

## Results

- Samples were exposed to He dominant plasmas with  $\text{He}/(\text{He}+\text{H}+\text{D}) > 85\%$ .
- Surface analysis of the samples will be conducted after retrieving them from the manipulator.



# Mitigation of tungsten induced plasma termination and identification of transient transport mechanisms (N. Tamura, H. Bouvain, A. Dinklage et al.)

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**Magnetic configuration:**  $(R_{ax}, \text{Polarity}, B_t, \gamma, B_q) = (3.60 \text{ m}, \text{CW}, 2.750 \text{ T}, 1.2538, 100.0\%)$

**Shots:** #191598 - #191631

## Goal of this experiment

- Investigate difference in electron and ion heating as rescue mechanism for tungsten TESPEL induced plasma termination.
- Investigate dependency of termination mitigation on ECRH deposition position

## Background & Motivation

- On-axis ECRH in H-plasma mitigates plasma termination induced by tungsten TESPEL
- It is presumed that off-axis ECRH as mitigation measure changes the time scales of the thermal quench
- It is presumed that pure ion heating changes the dynamics of the thermal quench

## Approach & Methodology

- Injection of  $3e17$  W tungsten TESPEL into ECRH-heated He/H plasmas:
  - ✓ Scan of delay time of additional  $\sim 1\text{MW}$  ECRH at  $\rho = 0.3$  with delay times  $\Delta t = [5, 10, 15, 20, 40, 80, 150, 200]$  ms
  - ✓ Scan of delay time of additional  $\sim 1\text{MW}$  ECRH at  $\rho = 0.5$  with delay times  $\Delta t = [5, 10, 15, 20, 40, 80, 150, 200]$  ms
  - ✗ Scan of delay time of additional ICRH  $\rightarrow$  trigger failed

# Mitigation of tungsten induced plasma termination and identification of transient transport mechanisms (N. Tamura, H. Bouvain, A. Dinklage et al.)

## Results

- 28 3e17 W TESPEL injected (89% successful delivery)
- Additional ECRH prevents He/H plasma termination induced by tungsten TESPEL
- Optimal delay time for off-axis ECRH ( $\rho = 0.3$ ):  $\Delta t = 15\text{ms}$
- Additional ECRH closer to on-axis deposition shows stronger mitigation effect

